dielectric materials for the low-refractive-index layers 12L include silicon dioxide (SiO₂) and magnesium fluoride (MgF₂).

[0035] Each layer of the optical thin film 12 is formed so as to have the convex portions 12A having the same shape as that of the convex portions 11A of the substrate 11. Each thickness of the layers of the optical thin film 12 is set according to a simulation based on a matrix method so that, for example, the optical thin film 12 reflects light in wavelength bands of the three primary colors, red, green, and blue, and transmits other light in at least a visible wavelength band. Specifically, the optical thin film 12 reflects red light having a wavelength of about 630 nm, green light having a wavelength of about 540 nm, and blue light having a wavelength of about 460 nm and transmits other light in at least a visible wavelength band. For example, each thickness of the layers is set in the range of 80 to 200 nm.

[0036] When light in the three primary color wavelength bands perpendicularly enter the optical thin film 12, the rays of the light have incident angles with respect to the surface of the optical thin film 12, at the convex portions 12A. Accordingly, a predetermined percentage of the light is diffused at angles twice the incident angles. More specifically, the maximum angle of the diffuse reflection of the rays depends on the angle θ formed by the straight line connecting a boundary point 11a with the center of the sphere defined by the spherical surface of the corresponding convex portion 11A and the normal to the surface of the top of the convex portion 11A, and it is 20, as shown in FIG. 3. Thus, a predetermined percentage of the light in the tree primary color wavelength bands is diffuse-reflected at reflection angles up to 20, and, consequently, the viewing angle of the screen is increased. The boundary point 11a, incidentally, is between the convex portions 11A and flat surfaces of the substrate 11.

[0037] The protective film 13 protects the optical thin film 12. The protective film 13 is also formed in the same shape as that of the surface of the optical thin film 12. However, the surface of the protective film 13 may be flat.

[0038] A method for manufacturing the projection screen 10 will now be described. The substrate 11 is prepared from a macromolecular material containing a black paint. The surface of the substrate 11 is subjected to, for example, embossing to form the plurality of convex portions 11A. The shape, curvature radius r, arrangement, area ratio, surface properties, and the like of the convex portions 11A are designed according to, for example, an optical simulation. Since the convex portions 11A allow light reflected from the optical thin film 12 to diffuse at a predetermined percentage, the range of diffuse reflection angle from the optical thin film 12 is appropriately set according to the design of the convex portions 11A. The regions of the surface of the substrate 11 between the convex portions 11A, incidentally, are flat.

[0039] The optical thin film 12 is deposited on the substrate 11 by, for example, sputtering. In this instance, the optical thin film 12 is formed so as to have convex portions 12A having the same shape as that of the convex portions 11A of the substrate 11. Also, the optical thin film 12 is a dielectric laminate formed by alternately laminating dielectric high-refractive-index layers 12H and dielectric low-refractive-index layers 12L having a refractive index lower than that of the high-refractive-index layers 12H. The thick-

nesses of the layers of the optical thin film 12 are set according to a simulation based on a matrix method so that, for example, the optical thin film 12 reflects light in wavelength bands of the three primary colors and transmits other light in at least a visible wavelength band. Finally, the protective film 13 is formed on the optical thin film 12. Thus, the projection screen 10 shown in FIG. 1 is completed.

[0040] Since, in the embodiment, the convex portions 11A of the substrate 11 is designed so as to allow light reflected from the optical thin film 12 to diffuse at a predetermined percentage, the optical thin film 12 overlying the substrate 11 can be provided with convex portions 12A having the same shape as that of the convex portions 11A of the substrate 11. Thus, the resulting screen has a simple structure.

[0041] The simulation based on the matrix method used for designing the optical thin film 12 will now be described. In this simulation, a dielectric laminate formed on a substrate is used as a model. If light enters the surface of this dielectric laminate at an angle from a light source, the light is multiple-reflected at the interfaces between the layers of the dielectric laminate. The rays of the multiple-reflected light interfere with each other depending on the wavelength of the light from the light source and the thickness and refractive index of the layers.

[0042] The matrix method is applied to this model of the dielectric laminate. Specifically, a matrix operation is performed so that optical lows, such as Maxwell's equations and Snell's law, satisfy boundary conditions of the layers of the dielectric laminate, using parameters, such as the wavelength of light, the thickness and refractive index of the substrate, the thickness and refractive index of the layers of the dielectric laminate, and the angle of incident light. Thus, optical properties of the dielectric laminate, such as transmittance and reflectance, are derived. According the derived optical properties, the dielectric laminate is designed.

[0043] The projection screen 10 is used for, for example, a front projector 20 using a GLV. FIG. 4 is a schematic illustration of the projector 20. The projector 20 includes a laser oscillator unit 21 for emitting narrow-band light beams in wavelength bands of the three primary colors. The laser oscillator unit 21 includes, for example, a laser oscillator 21R for emitting a red light beam having a wavelength of 642 nm, a laser oscillator 21G for emitting a green light beam having a wavelength of 532 nm, and a laser oscillator 21B for emitting a blue light beam having a wavelength of 457 nm.

[0044] The projector 20 also includes an optical system comprising a collimator lens unit 22, a cylindrical lens 23, a GLV 24, volume hologram elements 25, a galvanometer mirror 26, and a projection lens 27. The collimator lens unit 22 is essentially composed of a collimator lens 22R for red light, a collimator lens 22G for green light, and a collimator lens 22B for blue light. The GLV 24 includes a ribbon line 24R for red light, a ribbon line 24G for green light, and a ribbon line 24B for blue light. The volume hologram elements 25 are a first volume hologram element 25a and a second volume hologram element 25b.

[0045] The red light beam emitted from the red laser oscillator 21R, the green light beam emitted from the green laser oscillator 21G, and the blue light beam emitted from